



2811/12

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:	John T. Moore et al.	§	Group Art Unit:	2811
Serial No.:	09/496,794	§		
Filed:	February 2, 2000	§	Examiner:	Douglas W. Owens
For:	Trench Isolation for Semiconductor Devices	§	Atty. Dkt. No.:	MCT.0005D1US 97-0608.02US

Mail Stop **Amendment**
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

REPLY TO PAPER NO. 20041223

Sir:

In response to the office action mailed December 29, 2004, please amend the above-referenced patent application as follows:

Date of Deposit: March 2, 2005

I hereby certify under 37 CFR 1.8(a) that this correspondence is being deposited with the United States Postal Service as **first class mail** with sufficient postage on the date indicated above and is addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Cynthia L. Hayden
Cynthia L. Hayden